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CONFIRMATION NO. 4666

<b>SERIAL NUMBER</b> 10/501,522	<b>FILING OR 371(c) DATE</b> 07/16/2004 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 2812	<b>ATTORNEY DOCKET NO.</b> ABE-025
<b>APPLICANTS</b> Naoshi Adachi, Tokyo, JAPAN; Masahiko Nakamae, Tokyo, JAPAN;				
<b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP03/13514 10/22/2003				
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 2002-307478 10/22/2002				
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 8	<b>TOTAL CLAIMS</b> 11
Verified and Acknowledged _____ Examiner's Signature Initials			<b>INDEPENDENT CLAIMS</b> 2	
<b>ADDRESS</b> Kubovcik & Kubovcik The Farragut Building Suite 710 900 17th Street NW Washington ,DC 20006				
<b>TITLE</b> Pasted soi substrate, process for producing the same and semiconductor device				
<b>FILING FEE RECEIVED</b> 920	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees	
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